



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/783,835  
Filing Date ..... February 14, 2001  
Inventor ..... Nagano et al.  
Assignee ..... Honeywell International Inc.  
Group Art Unit ..... 1742  
Examiner ..... Ip, Sikyin  
Attorney's Docket No. .... 30-5000-(4015)-DIV3  
Title: Physical Vapor Deposition Target

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

To: Assistant Commissioner for Patents  
Washington, D.C. 20231

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

#15  
JTC 1700  
AUG 26 2002  
RECEIVED

Dear Sir:

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449 and copies of which are attached.

Citation of these references is respectfully requested.

A check in the amount of \$180.00 is enclosed to cover the fee specified under 37 C.F.R. § 1.17(p).

Respectfully submitted,

Dated: August 20, 2002

By: Jennifer J. Taylor  
Jennifer J. Taylor, Ph.D.  
Reg. No. 48,711

08/23/2002 NMOHAMM1 00000002 09783835

01 FC:126

180.00 OP